	Application No.	Applicant(s)
Nation of Allowability	10/780,014	ABBOTT ET AL.
Notice of Allowability	Examiner	Art Unit
	Tuan Quach	2814
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.31	6 (OR REMAINS) CLOSED in this ap ) or other appropriate communication RIGHTS. This application is subject t	plication. If not included n will be mailed in due course. <b>THIS</b>
1. This communication is responsive to		
2. The allowed claim(s) is/are <u>46-63</u> .		
3. $\boxtimes$ The drawings filed on <u>17 February 2004</u> are accepted by	the Examiner.	
<ul> <li>4. ☐ Acknowledgment is made of a claim for foreign priority up a) ☐ All b) ☐ Some* c) ☐ None of the:</li> <li>1. ☐ Certified copies of the priority documents have</li> <li>2. ☐ Certified copies of the priority documents have</li> <li>3. ☐ Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)).</li> <li>* Certified copies not received:</li> </ul>	e been received. e been received in Application No	
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDON! THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the requirements
5. A SUBSTITUTE OATH OR DECLARATION must be subminformal PATENT APPLICATION (PTO-152) which give		
6. CORRECTED DRAWINGS ( as "replacement sheets") mu  (a) including changes required by the Notice of Draftsper  1) hereto or 2) to Paper No./Mail Date  (b) including changes required by the attached Examiner Paper No./Mail Date  Paper No./Mail Date  Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in	son's Patent Drawing Review (PTO 's Amendment / Comment or in the ( 1.84(c)) should be written on the drawi	Office action of ngs in the front (not the back) of
7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT		
<ul> <li>Attachment(s)</li> <li>1. ☑ Notice of References Cited (PTO-892)</li> <li>2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)</li> <li>3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/Paper No./Mail Date 2/17/04</li> <li>4. ☐ Examiner's Comment Regarding Requirement for Deposit</li> </ul>	6. ☐ Interview Summary Paper No./Mail Da 708), 7. ☑ Examiner's Amend	ite
of Biological Material	9. Other	
		Thorn
		Tuan Quach Primary Examiner

U.S. Patent and Trademark Office PTOL-37 (Rev. 1-04) Application/Control Number: 10/780,014

Art Unit: 2814

## **EXAMINER'S AMENDMENT AND REASONS FOR ALLOWANCE**

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

In the insertion by applicant before line 5 on page 2 of the specification concerning the parent application (as delineated in the Preliminary Amendment filed February 17, 2004), after "July 9, 2002" - - now U.S. Pat. 6,723,597 - - is inserted.

This updates the status of the parent application.

The following is an examiner's statement of reasons for allowance:

Claims 46-63 are allowed primarily because the prior art do not teach the claimed invention in claims 46, 54, and 60, including with regard to a memory cell comprising a plurality of transistors above a semiconducting substrate, a plurality of local interconnects coupled to a doped region of one the transistors and positioned in an opening in a layer of boron phosphosilicate glass (BPSG) and a dielectric layer positioned above said BPSG layer, said dielectric layer being comprised of a material having a dielectric constant greater than approximately 6.0. There is no teachings or suggestion for the particular claimed combination of the BPSG and the dielectric layer as characterized to obtain the claimed structure and device in question and the associated problem and solution, e.g., the instant specification, page 3 line 24 to page 4 line 17, page 13 lines 11-19.

The prior art made of record include Arita et al., Venkatesan et al., Liou, and Held and those in the IDS filed February 17, 2004, and do not teach or suggest the claimed invention delineated above.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to examiner Quach whose telephone number (571)272-1717. The examiner can normally be reached on M - F from 8 to 4.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor Wael Fahmy can be reached on (571)272-1705. The fax phone number for the organization where this application or proceeding is assigned is (703)872-9306.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (571)272-1562.

Tuan Quach Primary Examiner